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Application/Control No.	Applicant(s)/Patent under Reexamination
10/036,182	LAAKSONEN, MIKA H.
Examiner	Art Unit
Heather R. Jones	2621

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SEARCHED						
Class	Subclass	Date	Examiner			
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INT	TERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
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SEARCH NO (INCLUDING SEARCH	TES STRATEGY)
	DATE	EXMR
Reapplied previous art rejection	3/5/2007	HRJ
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